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# ***Advanced Optics for Defense Applications: UV through LWIR II***

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# Contents

v	<i>Authors</i>
vii	<i>Conference Committee</i>

---

## OPTICAL DESIGN AND ANALYSIS I

---

10181 03	<b>Design of multiband optics using updated athermal/achromatic glass map [10181-2]</b>
10181 04	<b>Comparison of gimbal approaches to decrease drag force and radar cross sectional area in missile application [10181-3]</b>
10181 05	<b>Optimization of electro-optic phase shifters for integrated optical phased arrays [10181-4]</b>

---

## GRIN

---

10181 08	<b>Ternary versus binary material systems for gradient index optics (Invited Paper) [10181-8]</b>
10181 09	<b>Optical design of athermal, multispectral, radial GRIN lenses [10181-9]</b>
10181 0A	<b>Using GRIN to save 50% lens weight for an 8x rifle scope design [10181-10]</b>
10181 0B	<b>IR GRIN optics: design and fabrication [10181-11]</b>
10181 0C	<b>Athermal achromat theory for polymer gradient index optics [10181-12]</b>

---

## OPTICAL DESIGN AND ANALYSIS II

---

10181 0E	<b>Using material advances in chalcogenide glasses to improve imaging lenses in the 8-14 <math>\mu\text{m}</math> waveband [10181-13]</b>
10181 0F	<b>Digital correction of aberrations introduced by tilted plane-parallel plates in convergent beams [10181-15]</b>
10181 0G	<b>A system perspective on designing for field-dependent SNR in wide-angle point-source detection lenses [10181-16]</b>
10181 0H	<b>Expanding the mission plan for large scale telescope systems via skew path optical conditioners [10181-17]</b>

---

#### COATINGS AND FILTERS

---

- 10181 OJ    **Design of broadband anti-reflective metasurfaces based on an effective medium approach** [10181-19]
- 10181 OK    **Large area precision optical coatings by pulse magnetron sputtering** [10181-20]
- 10181 OM    **The angular dependence of optical interference filters in the Near IR can be greatly reduced through the use of novel coating materials and design strategies** [10181-22]
- 10181 ON    **Optimizing the effect of electric-field enhancement in nodular defects** [10181-23]
- 10181 OO    **Optimizing ITO for incorporation into multilayer thin film stacks for visible and NIR applications** [10181-32]
- 10181 OP    **Characterization of reactive plasma ion assisted HfO<sub>2</sub> films for low loss optical coatings in the DUV and MWIR** [10181-33]

---

#### MATERIALS AND MANUFACTURING I

---

- 10181 OR    **Structural modification of Ga-La-S glass for a new family of chalcogenides** [10181-25]
- 10181 OS    **Assessment of an approach to printed polymer lenses** [10181-35]

---

#### MATERIALS AND MANUFACTURING II

---

- 10181 OT    **Progress on high-performance rapid prototype aluminum mirrors** [10181-26]
- 10181 OU    **Chalcogenide molded freeform optics for mid-infrared lasers** [10181-27]

---

#### SELECT PAPERS IN OPTICS

---

- 10181 OV    **Mid-infrared imaging fiber bundle** [10181-29]
- 10181 OW    **UV scale calibration transfer from an improved pyroelectric detector standard to field UV-A meters and 365 nm excitation sources** [10181-30]
- 10181 OX    **Non-mechanical beam steering in the mid-wave infrared** [10181-34]

# Authors

Numbers in the index correspond to the last two digits of the seven-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first five digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Aghajani, A., 0R	Leischnig, Steffen, 0K
Alexay, Christopher, 0H	Levita, Zachary, 0O
Alvarez, Oseas, 0U, 0V	Lindberg, George, 0B
Anderson, Mike, 0X	Ma, Bin, 0N
Atalick, S., 0F	Macik, Dwayne D., 05
Bartzsch, Hagen, 0K	Madsen, Christi K., 05
Bayya, Shyam, 0B	Mait, J., 08
Beadie, G., 08, 0A, 0C	Marasco, Peter L., 0S
Bekele, Robel Y., 0X	Marshall, G., 0F
Boyd, Andrew M., 09	Mayer, T., 0J
Bravo, Tyler E., 05	McClain, Collin, 0B
Brown, Douglas, 0O	Milojkovic, P., 08
Bundesmann, Carsten, 0K	Morgan, K. A., 0R
Bungay, C., 0J	Morrish, Alan, 0O
Cangemi, Michael J., 0P	Myers, Jason D., 0X
Chenard, Francois, 0U, 0V	Myrick, Bruce H., 0T
Cheng, Xinbin, 0N	Naciri, Jawad, 0X
Chinhong, Christopher J., 0P	Nguyen, Vinh, 0B
Christodoulides, D. N., 0J	Nye, N. S., 0J
Cline, Robert A., 0G	Olson, S. Craig, 0G
Cooksey, C. C., 0W	Oudard, Jean Francois, 0P
Craig, C., 0R	Palmer, Troy A., 0H
Davis, Scott R., 0X	Pentecost, Seeley M., 05
Deegan, John, 0B	Platten, Jim E., 0P
D'Iallo, Michael J., 0P	Podobedov, V. B., 0W
Drescher, Andy, 0K	Ramsey, J. L., 03
Eppeldauer, G. P., 0W	Ravagli, A., 0R
Espinal, Francisco A., 05	Rivero-Baleine, C., 0J
Flynn, R. A., 08, 0A, 0C	Rommel, Scott D., 0X
Foot, Bob, 0S	Roschuk, Tyler, 0O
Frach, Peter, 0K	Sakarya, Doğan Uğur, 04
Franks, J. W., 0E	Sanghera, Jasbinder S., 0B, 0V, 0X
Frantz, Jesse A., 0X	Savastinuk, John, 0H
Gibson, Daniel, 0B, 0V	Schuster, N., 0E
Gloess, Daniel, 0K	Shaw, Leslie B., 0V, 0X
Goodman, Timothy D., 0G	Sodergren, Bennett, 0X
Goschurny, Thomas, 0K	Sparks, Andrew W., 0G
Gotjen, Henry, 0X	Spillmann, Christopher M., 0X
Greenhalgh, C., 0F	Sprague, Robert W., 0M
Grune, Harald, 0K	Swisher, A., 0J
Hartung, Ullrich, 0K	Szapiel, S., 0F
He, Tao, 0N	Taddeo, David, 0O
Heisig, Andreas, 0K	Thorpe, M., 0F
Hewak, D. W., 0R	Tuenge, S., 0J
Jiao, Hongfei, 0N	Unger, Blair, 03, 0B
Kolacz, Jakub S., 0X	Verplancke, J., 0E
Kotov, Mikhail, 0B	Vizgaitis, Jay, 0B
Leischnig, Lothar, 0K	Wamboldt, Leonard, 0P
	Wang, Jue, 0P

Wang, Ying-Ju, OX  
Wang, Zhanshan, ON  
Weatherby, E. C., OR  
Woodard, Kenneth S., OT  
Yi, Allen, OU  
Zeimpekis, I., OR  
Zhang, Jinlong, ON  
Ziemkiewicz, Michael, OX

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- 1    Optical Design and Analysis I  
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    **Craig Olson**, L-3 Sonoma EO (United States)
- 2    Opto-Mechanics  
    **Kyle R. Bryant**, U.S. Army AMRDEC (United States)  
    **Craig Olson**, L-3 Sonoma EO (United States)
- 3    GRIN  
    **Peter L. Marasco**, Air Force Research Laboratory (United States)  
    **Jasbinder S. Sanghera**, U.S. Naval Research Laboratory  
    (United States)
- 4    Optical Design and Analysis II  
    **Christopher Alexay**, StingRay Optics, LLC (United States)  
    **Peter L. Marasco**, Air Force Research Laboratory (United States)
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    **Jue Wang**, Corning Specialty Materials, Inc. (United States)  
    **Jasbinder S. Sanghera**, U.S. Naval Research Laboratory  
    (United States)
- 6    Materials and Manufacturing I  
    **Alan Symmons**, LightPath Technologies, Inc. (United States)  
    **John Deegan**, Rochester Precision Optics, LLC (United States)
- 7    Materials and Manufacturing II  
    **Alan Symmons**, LightPath Technologies, Inc. (United States)  
    **John Deegan**, Rochester Precision Optics, LLC (United States)
- 8    Select Papers in Optics  
    **Guy Beadie**, U.S. Naval Research Laboratory (United States)